

Notice of References Cited	Application/Control No. 10/758,276	Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner Shih-wen Hsieh	Art Unit 2861	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,631,973	10-2003	Edamura, Tetsuya	347/30
	B	US-			
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	D	US-			
	E	US-			
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	I	US-			
	J	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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